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REMARKS

Status of Claims

Claims 1-32 are pending, of which claim 1 is an active independent claim. Favorable reconsideration of the application in light of the following comments is respectfully solicited.

Claim Rejection - 35 U.S.C. § 103

Claims 1-32 were rejected under 35 U.S.C. § 103(a) as being unpatentable over Fukaya et al. (JP 2001-353603) in view of Hirano et al. (USP 6,066,399), in view of Sheeja et al. ("Tribological properties and adhesive strength of DLC coatings prepared under different substrate bias voltages"), as evidenced by Ohring ("Materials Science of Thin Films, Deposition and Structure"). This rejection is traversed for at least the following reasons.

Applicants respectfully submit that the Examiner's reliance on Hirano is inappropriate because Hirano is directed to a hard carbon thin film including a carbon-carbon bond, but fails to disclose the coated film formed from "a carbide, a nitride, an oxide, a carbonitride, an oxycarbide, an oxynitride, or a carbide-nitride-oxide of at least one element selected from IVagroup elements, Va-group elements, Vla-group elements in the element periodic table, Al, B, Si and Ge, or a solid solution thereof," as recited by amended claim 1. Applicants respectfully submit that it is well known that the concept of the sp²/sp³ ratio is specific to the carbon-carbon bonding, which is also evidenced by Hirano's disclosure at col. 2, lines 42-52. This portion states:

The sp^2 and sp^3 carbon-carbon bondings indicate different forms of chemical bonding between carbon atoms. It is generally known that the carbon-carbon bonding in the diamond thin film is predominantly sp^3 while that in a graphite is predominantly sp^2 . It is also known that an amorphous diamond-like carbon thin film, as well as a partially crystalline diamond-like carbon thin film, may have a structure in which both sp^2 and sp^3 carbon-carbon bondings are distributed

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therethrough. In the present invention, such a sp²/sp³ ratio is characteristically varied in a film thickness direction as described earlier.

Therefore, the concept of the sp²/sp³ ratio in Hirano would not have been combined with the coated film of a carbide, a nitride, an oxide, a carbonitride, an oxycarbide, an oxynitride, or a carbide-nitride-oxide of at least one element selected from IVa-group elements, Va-group elements in the element periodic table, Al, B, Si and Ge, or a solid solution thereof, which do not contain the carbon-carbon bonding. As such, there in no motivation or suggestion to combine Hirano with Fukaya to arrive at the present subject matter.

Further, Hirano changes the chemical composition to vary the sp²/sp³ ratio. In contrast, the variation in strength of compressive stress in Fukaya does not involve changing of the chemical composition or bonding structure between atoms. Fukuya discloses that the stress distribution is attained only in one layer having a single chemical composition. Therefore, a person skilled in the art would not combine the coated film in Fukaya, which does not employ changing of a chemical composition or bonding structure between atoms with the film in Hirano, which employs changing of a chemical composition or bonding structure between atoms.

Based on the foregoing, Applicants respectfully submit that claim 1 and all claims dependent thereon are patentable over the cited references.

Regarding claims 23-25, Applicants submit that Hirano dose not disclose the subject matter of these claims. The Examiner asserts that stepwise increase/decrease of the stress, as shown in FIG. 15 of Hirano, discloses the subject matter of claims 23-25. However, the Example 5 of Hirano, which includes FIGS. 7 and 15-17, discloses a hard carbon film having a graded structure in which the sp²/sp³ ratio (i.e., stress) once decrease in a stepwise manner and then increases in a stepwise manner (see, col. 13, lines 42-49 of Hirano). It is very likely that the sp²/sp³ ratio distribution is similar to FIG. 6 of Hirano. As such, it is clear that Hirano fails to

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disclose the stress distribution as defined by claims 23-25. Thus, claims 23-25 are patentable

over the cited references on their own merit in addition to the dependency upon claim 1.

Thus, it is requested that the Examiner withdraw the rejection of claims 1-32 under 35

U.S.C. § 103(a).

Conclusion

Having fully responded to all matters raised in the Office Action, Applicants submit that

all claims are in condition for allowance, an indication for which is respectfully solicited. If

there are any outstanding issues that might be resolved by an interview or an Examiner's

amendment, the Examiner is requested to call Applicants' attorney at the telephone number

shown below

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is

hereby made. Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted.

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